



PATENT
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Customer No.: 29344

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Eung-Joon Lee, *et al.*
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Group Art Unit: 2891
Date of Notice of Allowance: September 14, 2005
Title: METHOD FOR FORMING A METAL SILICIDE LAYER
IN A SEMICONDUCTOR DEVICE

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

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11-16-05

Date

Vanessa Marakas
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TRANSMITTAL LETTER

Sir:

Enclosed herewith for filing in the above-identified patent application please find the following:

1. Fee(s) Transmittal PTOL-85;
2. Check in the amount of \$1,730.00 to cover Issue Fee, ten (10) advance-order copies of the printed patent and the Publication Fee; and
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In connection with the foregoing matter, please charge any additional fees which may be due, or credit any overpayment, to Deposit Account Number 50-1798. A duplicate copy of this letter is provided for this purpose.

Respectfully submitted,

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